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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:  
Ravi Iyer

Serial No.: 09/059,865

Filed: April 14, 1998

For: PLANARIZATION USING PLASMA  
OXIDIZED AMORPHOUS SILICON

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Group Art Unit: 2813

Examiner: Nguyen, T.

Atty. Docket: MICS:0015--2/FLE  
93-118.02

Mail Stop Non-Fee Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313

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November 10, 2003 Date	 John M. Rariden

Sir:

**AMENDMENT**

In response to the Official Action mailed on July 9, 2003, please amend the above-identified application as follows:

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